



FORM PTO 1449 (modified)		AT&T DOCKET NO. 00684.103076		APPLICATION NO. 10/529,893		
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		APPLICANT Natsuhiko MIZUTANI				
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		FILING DATE October 17, 2005		GROUP 1763 2851		
July 21, 2006						
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS
MJ		US-7,050,144 B2	05/23/2006	Mizutani et al.	355	19
		2004/0121245 A1	06/24/2004	Inao et al.	430	5
		2005/0063445 A1	03/24/2005	Mizutani et al.	372	94
		2005/0064303 A1	03/24/2005	Yamada et al.	430	5
		2006/0003236 A1	01/05/2006	Mizutani et al.	430	5
	↓	2006/003269 A1	01/05/2006	Ito et al.	430	323
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)						
EXAMINER <i>Michael Lin</i>		DATE CONSIDERED <i>6/28/07</i>				

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1



FORM PTO 1449 (modified)		ATTY DOCKET NO. 00684.103076		APPLICATION NO. 10/529,893			
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		APPLICANT Natsuhiko MIZUTANI					
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		FILING DATE April 1, 2005 10/17/05			GROUP Unassigned 2851		
May 3, 2005		U.S. PATENT DOCUMENTS					
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
mlf		US 6,171,730 B1	01/09/2001	Kuroda et al.	430	5	
↓		US 6,187,482 B1	02/13/2001	Kuroda et al.	430	5	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
mlf		1 150 162 A2	10/31/2001	Europe			
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
mlf		International Search Report mailed February 7, 2005, issued in International Application No. PCT/JP2004/011648.					
↓		Written Opinion mailed February 7, 2005, issued in International Application No. PCT/JP2004/011648.					
↓		Alkaisi, Maan M., et al., "Nanolithography in the Evanescent Near Field," <u>Advanced Materials</u> , 13, No. 12-13, July 4, 2001, pp. 877-887.					
EXAMINER <i>mlf</i>		DATE CONSIDERED <i>6/28/07</i>					

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1